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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AF  
2815

Applicant: Zhiping Yin et al.

Title: OXYGEN PLASMA TREATMENT FOR NITRIDE SURFACE TO REDUCE PHOTO FOOTING

Docket No.: 303.531US1  
Filed: March 1, 1999  
Examiner: Jose Diaz



Serial No.: 09/259762  
Due Date: March 8, 2004  
Group Art Unit: 2815

MS AF

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

- ☒ A return postcard.
- ☒ An Amendment and Response under 37 CFR 1.116 (7 Pages).

Please consider this a **PETITION FOR EXTENSION OF TIME** for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

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By: Janal M. Kalis  
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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 8th day of March, 2004.

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